

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No. 9634

Group Art Unit: 2851

Examiner: Peter B. Kim

Inventor(s): Yeong-Song Yen et al.

Serial No.: 10/033,891

Filing Date: January 3, 2002

Title: PHOTOLITHOGRAPHY PROCESS WITH MULTIPLE EXPOSURES

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OCT 05 2004

Attorney Docket No. 46602-00403

AMENDMENT UNDER 37 C.F.R. §1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby acknowledge receipt of the Notice of Allowance and Fee(s)

Due mailed October 7, 2004.

Please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 10 of this paper.

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